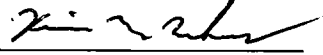


**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
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CONCERNING A SUBMISSION UNDER 35 U.S.C. 371**

In re Application of: Ling CHEN, et al.	§ § §	Int'l Application No.: PCT/US2004/016715
Serial No.: 10/590,448	§ §	Int'l Filing Date: 27 May 2004 (27.05.2004)
Filed: August 24, 2006	§ §	Priority Date: 27 May 2003 (27.05.2003)
For: METHOD AND APPARATUS FOR GENERATING A PRECURSOR FOR A SEMICONDUCTOR PROCESSING SYSTEM	§ § § § §	

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SECOND PRELIMINARY AMENDMENT

Prior to examination, please amend the above-identified application as follows.

Amendments to the Specification begin on page 2 of this paper. **The Remarks** begin on page 3 of this paper.